



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 09/484,421 Confirmation No. : 9681  
Applicant : Martin DUBS, et al.  
Filed : January 18, 2000  
TC/A.U. : 1745  
Examiner : Gregg Cantelmo  
Docket No. : 080310.48561  
Customer No. : 23911  
Title : Sputter Chamber as Well as Vacuum Transport Chamber  
and Vacuum Handling Apparatus with Such Chambers

AMENDMENT

Mail Stop 313(c)  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted along  
with a Petition To Withdraw Application From Issue under 37 C.F.R. §1.313.

**Amendments to the Claims** are reflected in the listing of claims which  
begins on page 2 of this paper.

**Remarks** begin on page 3 of this paper.